## INFORMATION DISCLOSURE CITATION (37 CFR 1.97)

Application Number
Filing Date
First Named Inventor Rutten
Group Art Unit
Examiner Name
Attorney Docket US 018180

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2	~	•••	"Introducing WOW Technology", http://www.formfactor.com/about/wow/wow_pg2.html "Introducing WOW Technology", http://www.formfactor.com/about/wow/wow_pg2.html "Focus on FormFactor", THE FDM Communications on FormFactor and Factor
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	Examiner
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Ì	Examiner: Initial if reference considerations
I	Draw line through citation if not in conformance and not consider with MPEP 609;
ι	Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to the Applicant.